



03500.014179.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOICHI ANDO ET AL.)
Application No.: 09/722,454)
Filed: November 28, 2000)
For: METHOD FOR MANUFACTURING)
ELECTRON BEAM DEVICE,)
METHOD FOR MANUFACTURING)
IMAGE FORMING APPARATUS,)
ELECTRON BEAM DEVICE AND)
IMAGE FORMING APPARATUS)
MANUFACTURED THOSE)
MANUFACTURING METHODS,)
METHOD AND APPARATUS FOR)
MANUFACTURING ELECTRON)
SOURCE, AND APPARATUS FOR)
MANUFACTURING IMAGE)
FORMING APPARATUS)

Examiner: M. Santiago
Group Art Unit: 2879

February 9, 2004

FEB 24 2004

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR APPROVAL TO MAKE DRAWING CHANGES

Sir:

With the Examiner's approval, Applicants propose to amend Figs. 93-97 in
the above-identified application as shown by the attached replacement sheets.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope
addressed to: Commissioner for Patents, Washington, D.C. 20231 on
February 9, 2004.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

Signature

February 9, 2004

Date of Signature



The proposed changes include inserting "Prior Art" in each mentioned Figure.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Attorney for Applicants

Registration No. 42476

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